United States Patent [19]

Takahashi et al.

[11] **Patent Number: Des. 288,814**

[45] **Date of Patent: ** Mar. 17, 1987**

[54] **DATA PROCESSOR FOR MEASURING INSTRUMENTS**

[75] Inventors: **Seigo Takahashi; Takeji Nishimura; Hiroshi Koizumi,** all of Kawasaki, Japan

[73] Assignee: **Mitutoyo Mfg. Co., Ltd.,** Tokyo, Japan

[**] Term: **14 Years**

[21] Appl. No.: **612,813**

[22] Filed: **May 22, 1984**

[30] **Foreign Application Priority Data**

Nov. 25, 1983 [JP] Japan 58-51154

[52] **U.S. Cl.** **D14/100;** D10/46

[58] **Field of Search** .... D10/46, 101, 103, 75, D10/78; D13/35, 4 C; D14/100, 107, 114; 324/72.5, 156, 114, 115

[56] **References Cited**

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Attorney, Agent, or Firm—Flynn, Thiel, Boutell & Tanis

[57] **CLAIM**

The ornamental design for a data processor for measuring instruments, as shown and described.

DESCRIPTION

FIG. **1** is a perspective view of a data processor for measuring instruments showing our new design;

FIG. **2** is a front elevational view thereof;

FIG. **3** is a rear elevational view thereof;

FIG. **4** is a top plan view thereof;

FIG. **5** is a bottom plan view thereof;

FIG. **6** is a left side elevational view thereof;

FIG. **7** is a right side elevational view thereof;

FIG. **8** is a sectional view taken on line **8—8** in FIG. **2;** and

FIG. **9** is a sectional view taken on line **9—9** in FIG. **2.**

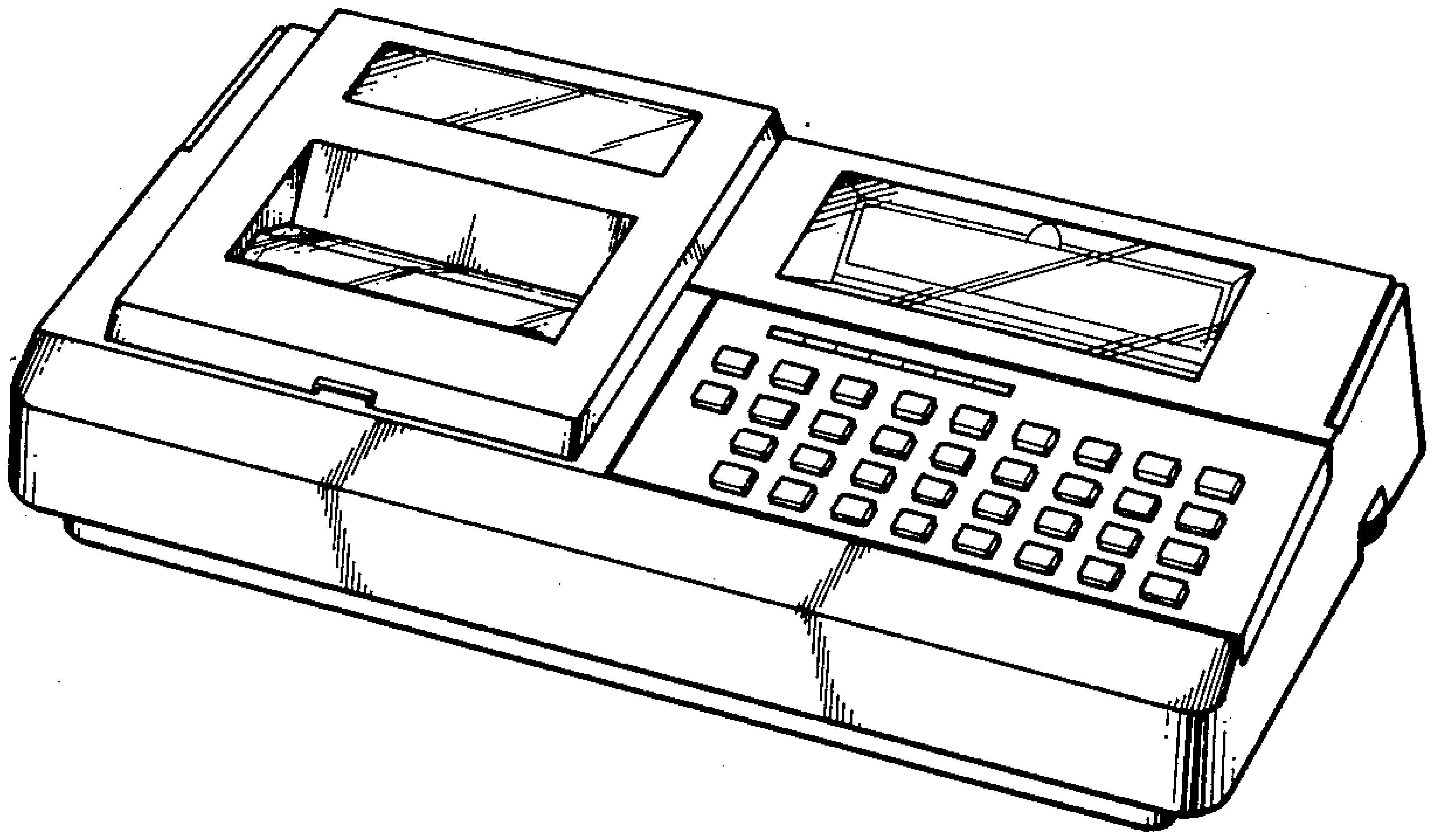

FIG. 1

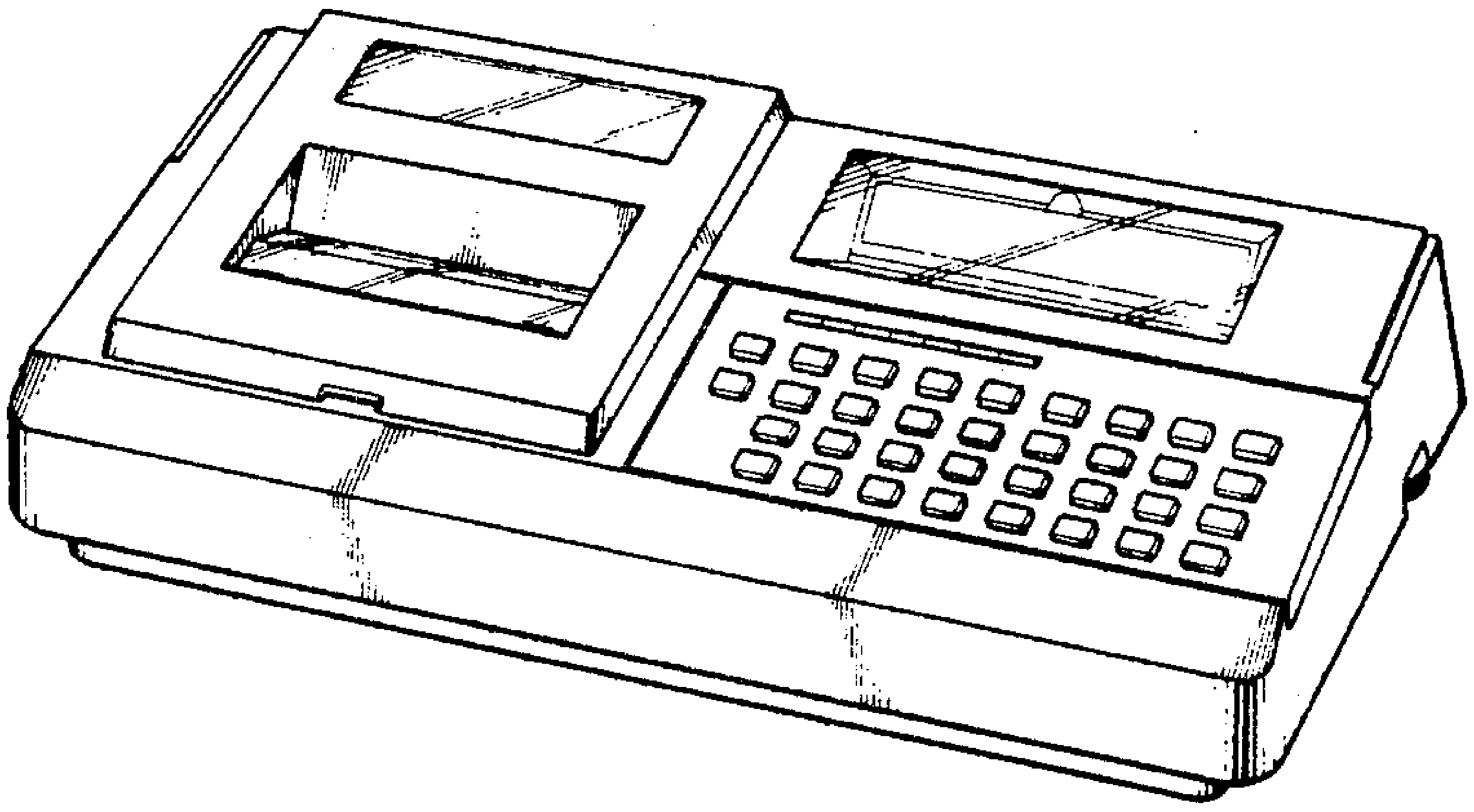

FIG. 2

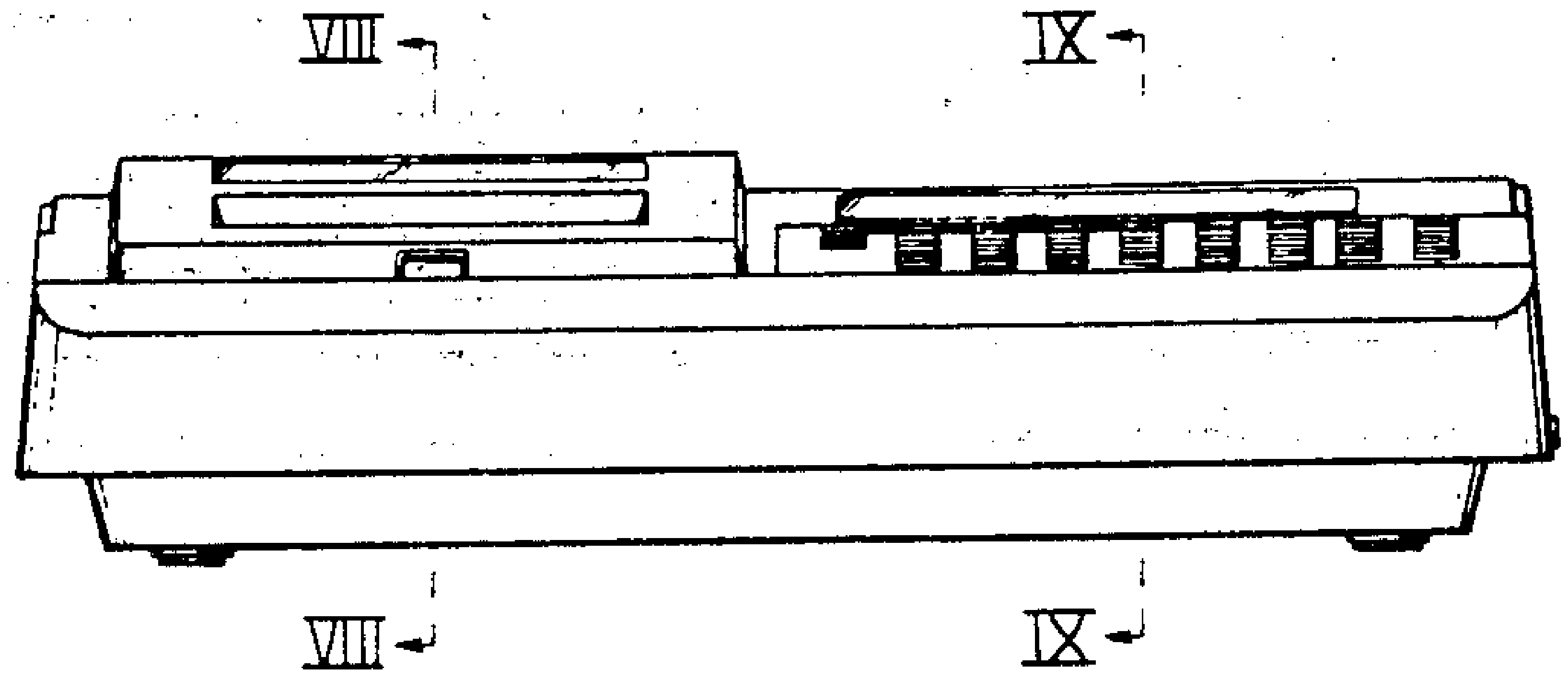

FIG. 3

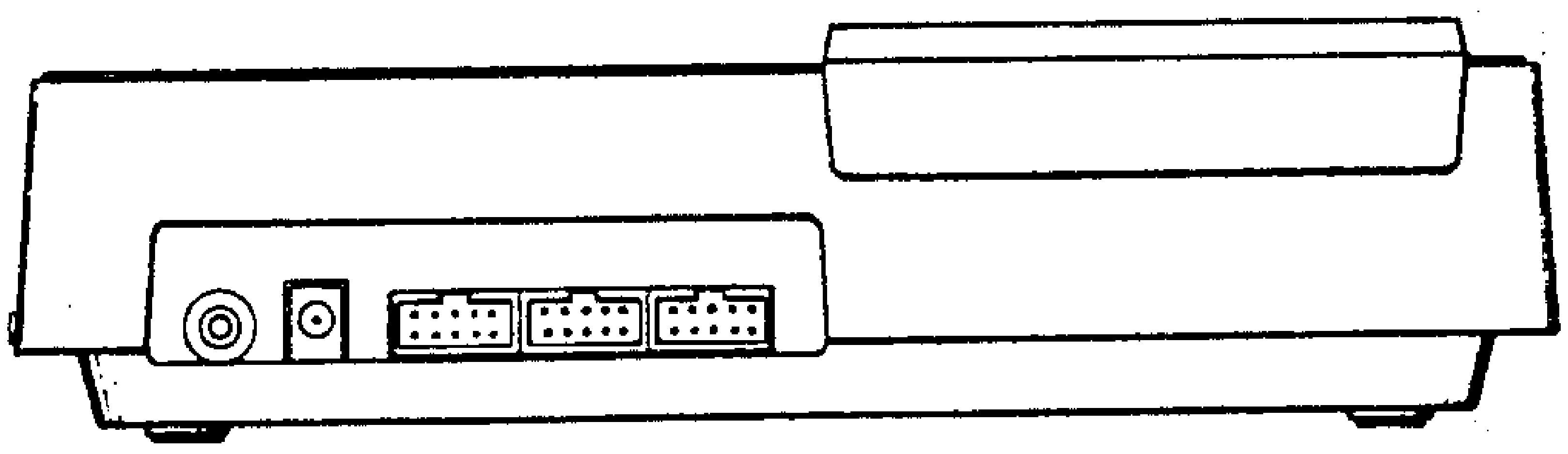

FIG. 4

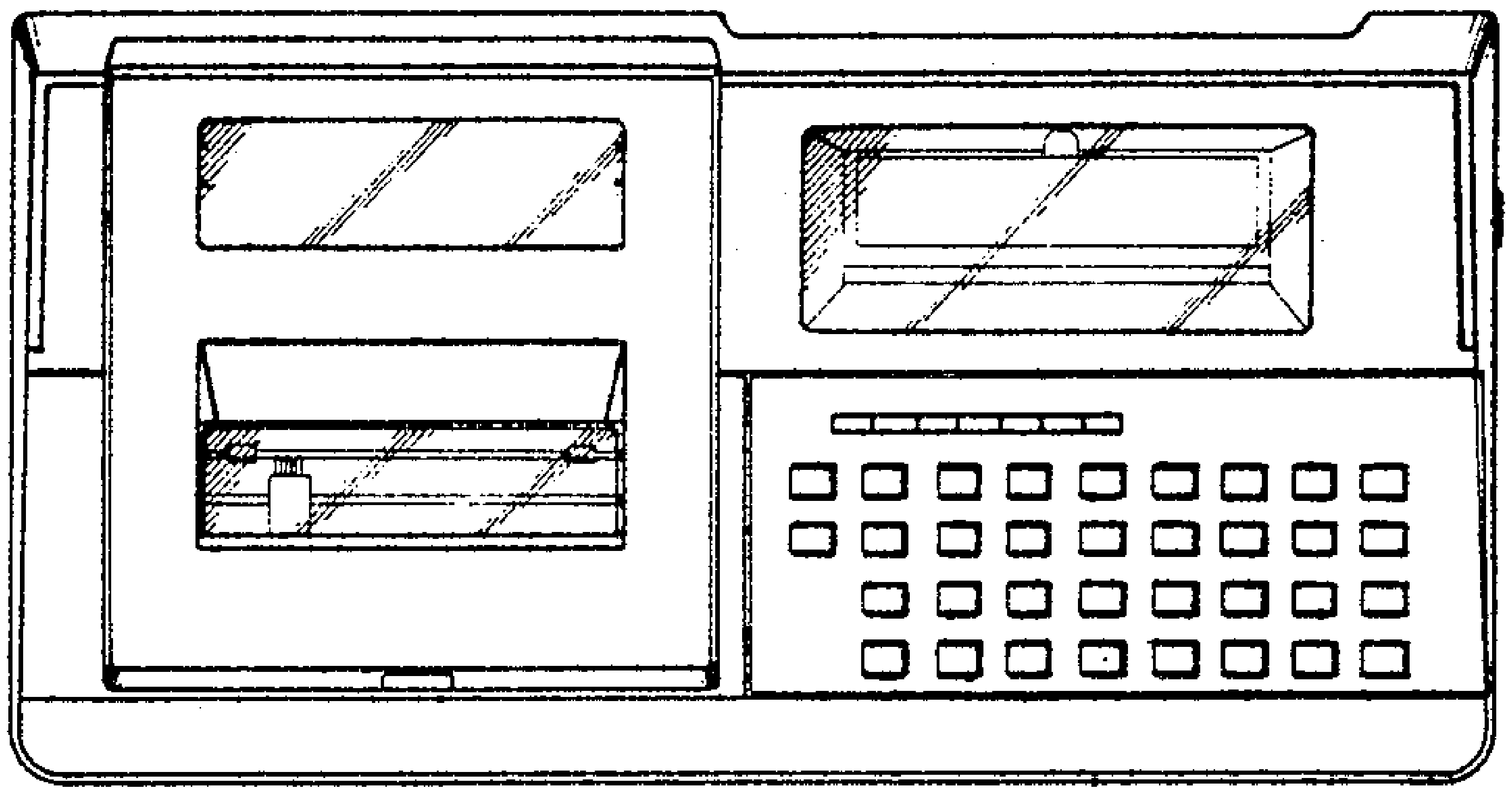

FIG. 5

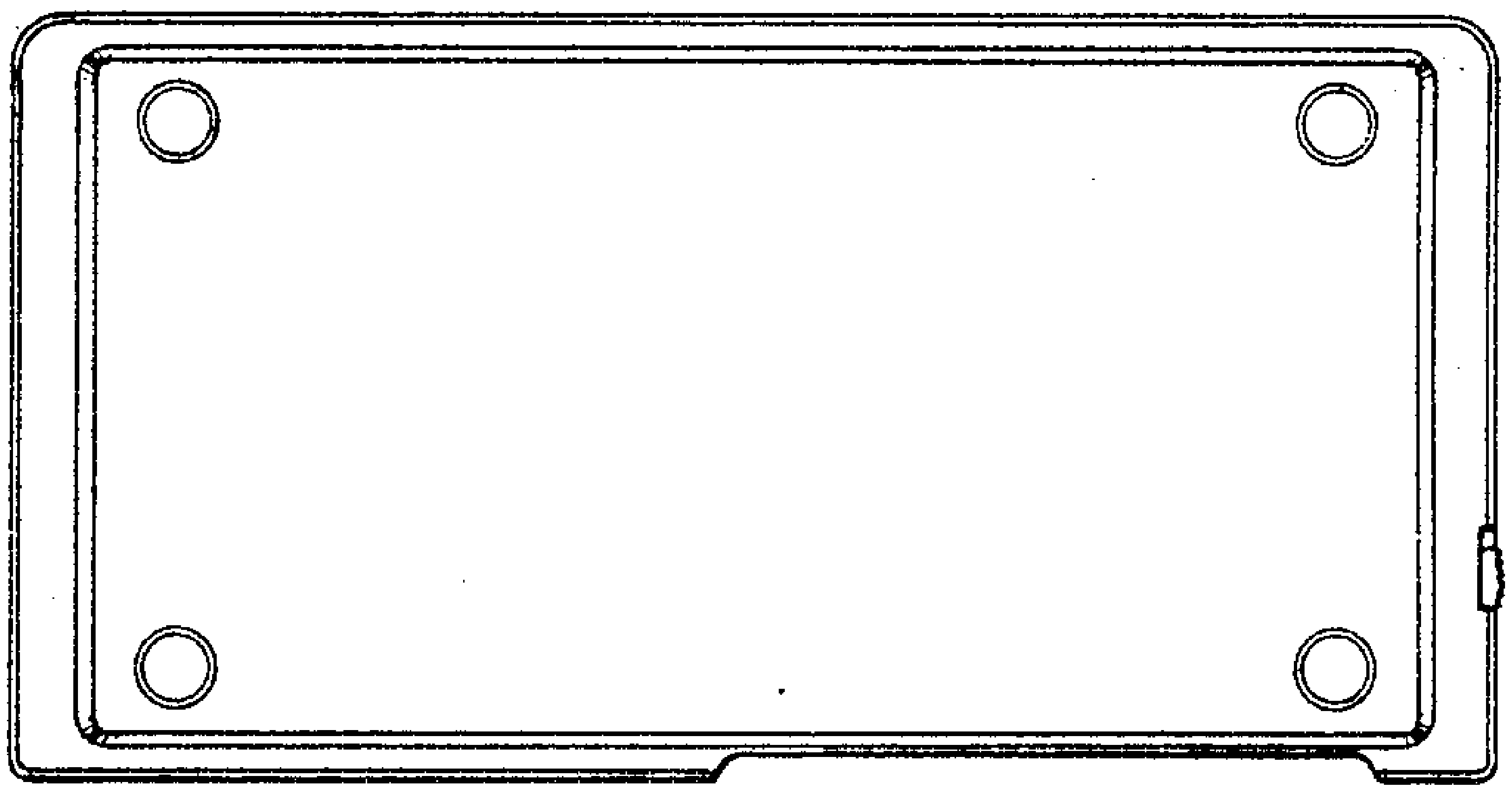

FIG. 6

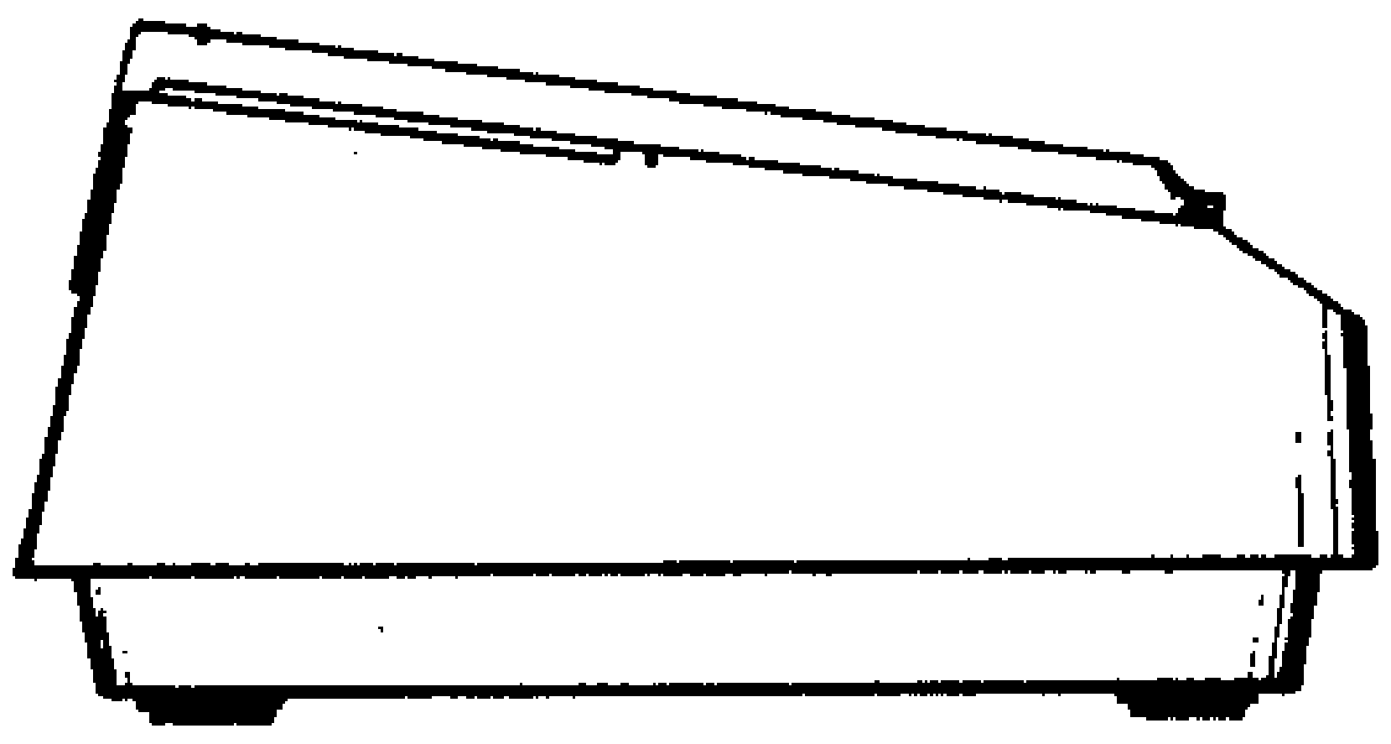

FIG. 7

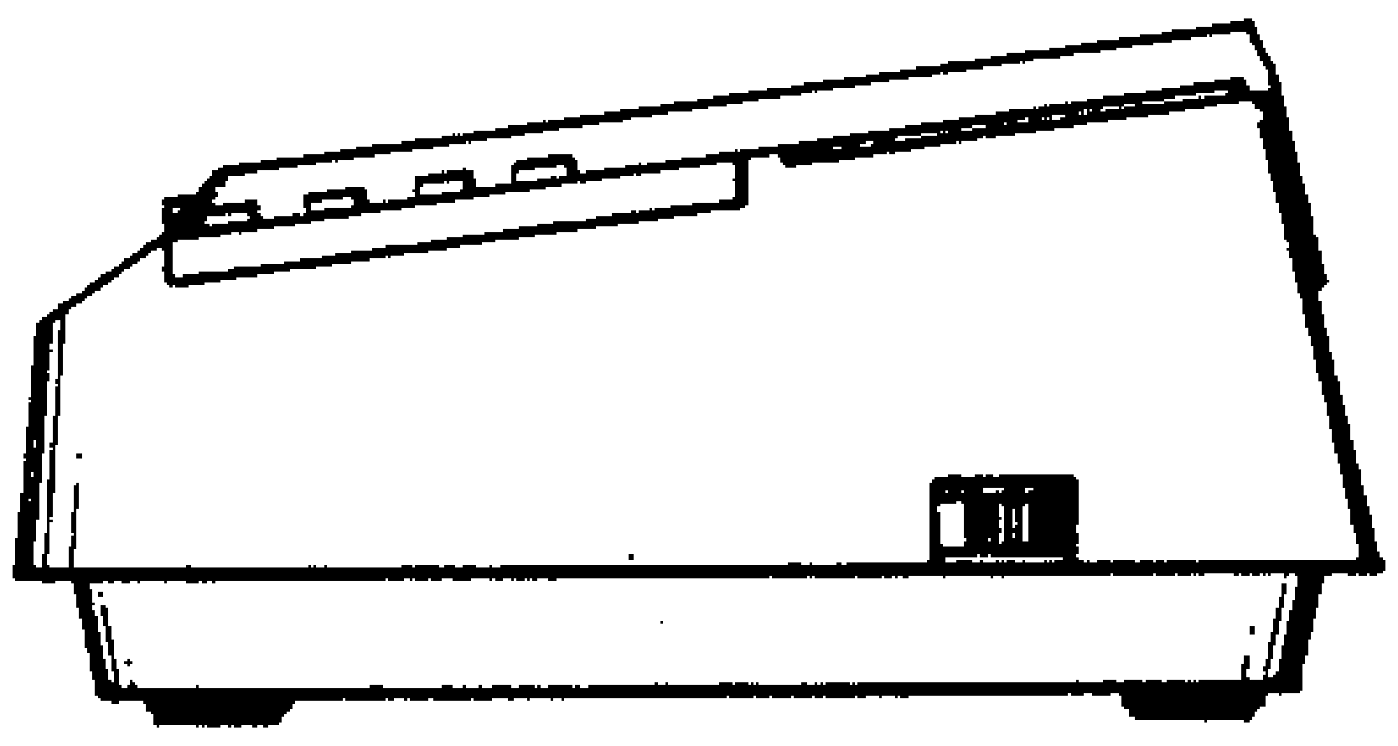

FIG. 8

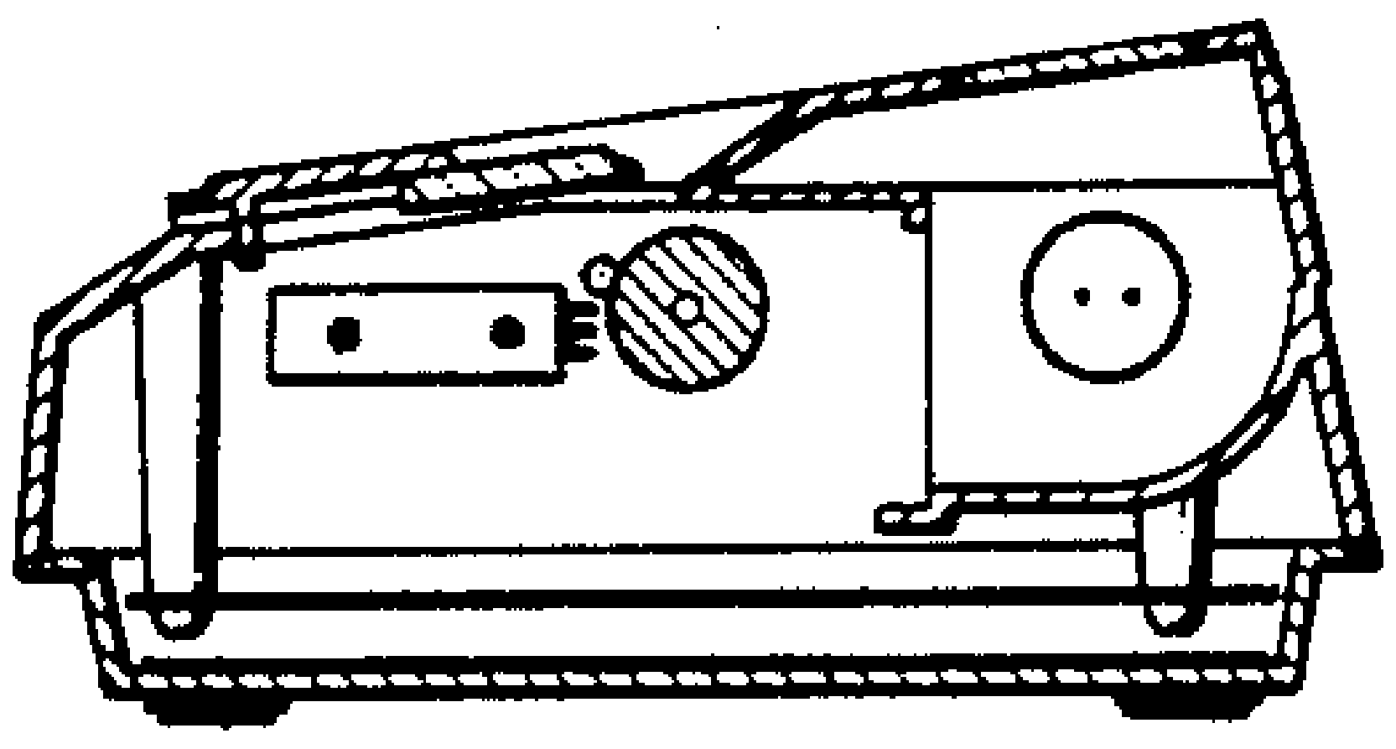

FIG. 9